

IPW

03500.017456

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: H. M. Lee
KAZUHIRO KAGAMI ET AL.)
: Group Art Unit: 2823
Application No.: 10/627,645)
:
Filed: July 28, 2003)
:
For: BASE PATTERN FORMING)
MATERIAL FOR ELECTRODE :
AND WIRING MATERIAL)
ABSORPTION, ELECTRODE :
AND WIRING FORMING)
METHOD, AND METHOD OF :
MANUFACTURING IMAGE)
FORMING APPARATUS : June 2, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

A. Introductory Comments

In response to the Office Action dated March 10, 2004, please amend the application as follows and consider the following remarks.